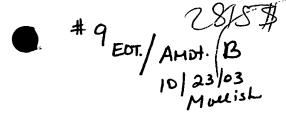


Docket No. F-7337



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant** 

Shigeki SAKAI, et al.

Serial No.

10/090,851

Filed

March 4, 2002

For

SEMICONDUCTOR NONVOLATILE STORAGE

ELEMENT AND METHOD OF FABRICATING THE

**SAME** 

Group Art Unit

2815

Examiner

Jesse A. Fenty

Confirmation No.

5906

Customer No.

000028107

## Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 October 6, 2003 .

Herbert F. Ruschmann\_

(Name)

(Signature)

## **AMENDMENT**

MAILSTOP FEE AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

10/10/2003 CCHAU1

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## **INTRODUCTORY COMMENTS:**

Sir:

In response to the Office Action of June 6, 2003, please amend the aboveidentified patent application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.